REMARKS

Claims 1, 2 and 4-5 are pending and under consideration in the above-identified application and Claims 3 and 6 were previously cancelled.

In the Office Action, Claims 1, 2 and 4-5 were rejected.

In this Amendment, Claim 1 is amended. No new matter has been introduced as a result of this Amendment.

Accordingly, Claims 1, 2, 4 and 5 remain at issue.

I. 35 U.S.C. § 103 Obviousness Rejection of Claims 1-2 and 4-6

Claims 1-2 and 4-6 were rejected under 35 U.S.C. § 103(a) as being unpatentable over Tsuda et al. ("Tsuda") (U.S. Patent No. 5,936,688) in view of Nakamura et al. ("Nakamura") (U.S. Patent No. 5,847,789), and in further view of Itoh et al. ("Itoh") (U.S. Patent No. 6,094,252). Although, Applicants respectfully traverse this rejection, to further prosecution, Claim 1 has been amended to clarify the invention and remove any ambiguities that may have been at the basis of this rejection.

Claim 1 is directed to a method of manufacturing a diffusing reflector.

In the relevant part, Claim 1 recites

"said first resin film is patterned by straight connected lines that form a continuous polygonal pattern, said straight lines providing a substantially uniform gap between said adjacent polygonal pillar-shaped bodies thereby forming a rectilinear honeycomb-like pattern,

said gap having a size equal to about a minimum resolution of said photolithography, and

a thickness of the second resin is about 500nm."

Referring to Applicants' Figure 2, adjacent pillar-shaped bodies isolated from each other by polygonal patterning a resin film with photolithography are separated by a continuous and substantially uniform gap thereby forming a rectilinear honeycomb-like pattern. The width or size of the gap between any two adjacent polygonal pillar-shaped bodies is set to about 1 um which is almost equal to the minimum resolution of the photolithography process.

This is clearly unlike *Tsuda*, *Nakamura*, and *Itoh* taken singly or in combination with each other

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This Examiner states that *Tsuda* discloses the resin film (34a) is patterned by straight connected lines that form a continuous polygon pattern and points to Column 13, lines 33 – 40 for support.

However, as illustrated in FIGs. 6G - 6J, 9H - 9L, 20H - 20L, and 21G - 21J of Tsuda, the dimples (pillar-shaped bodies), being either circular or polygonal, are too sparsely distributed or formed on the supporting substrate to form a continuous and substantially uniform concave gap having a size equal to about a minimum resolution of the photolithography between any two adjacent pillar-shaped bodies thereby forming a rectilinear honeycomb-like pattern, after the reflow process, as required by Claim 1.

Moreover, the claimed second resin film has a thickness of about 500nm, which when formed in the gap having a size equal to about a minimum resolution of the photolithography, provides a concave gap between any two adjacent isolated pillar-shaped bodies. As such, upper end portions of any two adjacent isolated pillar-shaped bodies are higher than a lower end portion of the concave gap in the thickness direction of the diffusing reflector, thereby minimizing an occurrence of a flat surface area on the substrate.

As the Examiner acknowledged, *Tsuda* teaches that the least interval (gap) between the resultant adjacent protrusions (pillar-shaped bodies) 112b is as small as about 0.5µm. As such, a second resin formed in this gap with a thickness of 500 nm creates a flat gap between the pillar-shaped bodies, rather than a concave gap as required by Claim 1.

Further, both Nakamura and Itoh also fail to teach or suggest this gap limitation of Claim 1.

Thus, Claim 1 is patentable over *Tsuda*, *Nakamura*, and *Itoh* taken singly or in combination with each other, as are dependent Claims 2, 4 and 5, for at least the same reasons.

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II. Conclusion

In view of the above amendments and remarks, Applicant submits that Claims 1, 2, 4 and 5 are clearly allowable over the cited prior art, and respectfully requests early and favorable notification to that effect.

Respectfully submitted,

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